

LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S
INFORMATION DISCLOSURE STATEMENT

Applicant:

Ji-Yong PARK, et al.

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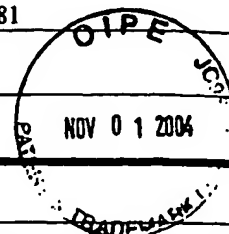
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Filing Date:

February 18, 2004

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2811



REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINERS INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)
<i>me</i>	5,774,824 <i>h</i>	Apr. 28, 1998	Kousai et al.			
<i>me</i>	5,932,893	Aug. 3, 1999	Miyanaaga et al.			
<i>me</i>	6,177,301 B1	Jan. 23, 2001	Jung			
<i>me</i>	6,479,837	Nov. 12, 2002	Ogowa et al.			
<i>me</i>	6,506,669 B1	Jan. 14, 2003	Kuramasu et al.			
<i>me</i>	6,521,473 B1	Feb. 18, 2003	Jung			
<i>me</i>	6,605,497 B2	Aug. 12, 2003	Yamazaki et al.			
<i>me</i>	6,692,996 B2	Feb. 17, 2004	Lee et al.			
<i>me</i>	6,727,522 B1	Apr. 27, 2004	Kawasaki et al.			
<i>me</i>	6,741,621 B2	May 25, 2004	Asano			
<i>me</i>	6,759,679 B2	Jul. 6, 2004	Lee			
<i>me</i>	6,781,162 B2	Aug. 24, 2004	Yamazaki et al.			
<i>me</i>	2004/0077132 A1	Apr. 22, 2004	Lee			
<i>me</i>	2003/0068836 A1	Apr. 10, 2003	Hongo et al.			
<i>me</i>	2003/0089907	May 15, 2003	Yamaguchi et al.			
<i>me</i>	2003/0102508 A1	Jun. 5, 2003	Lee			
<i>me</i>	2003/0193069 A1	Oct. 16, 2003	Park et al.			
<i>me</i>	2003/0235971	Dec. 25, 2003	Yamazaki et al.			
<i>me</i>	2004/0004219 A1	Jan. 8, 2004	Lee et al.			
<i>me</i>	2004/0040938 A1	Mar. 4, 2004	Yamazaki et al.			
<i>me</i>	2004/0132266 A1	Jul. 8, 2004	Yamazaki et al.			
<i>me</i>	2004/0144988 A1	Jul. 29, 2004	Jung			
<i>me</i>	2004/0164300 A1	Aug. 26, 2004	Yamazaki et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<i>me</i>	Abstract of KR 2003-0059593	Oct. 7, 2003	Korea			<input checked="" type="checkbox"/> Abstract
<i>me</i>	Abstract of KR 2003-0046101	Dec. 6, 2003	Korea			<input checked="" type="checkbox"/> Abstract
						<input type="checkbox"/>
						<input type="checkbox"/>

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

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Meun C. Jhu

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Page 1 of 1

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U.S. PATENT DOCUMENTS

EXAMINERS INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<i>m</i>	JP5107561	April 30, 1993	JAPAN	G02F1	136	<input checked="" type="checkbox"/> Abstract <input type="checkbox"/>
<i>m</i>	JP2001109399	April 20, 2001	JAPAN	G09F9	30	<input checked="" type="checkbox"/> Abstract <input type="checkbox"/>
<i>m</i>	JP2001290441	October 19, 2001	JAPAN	G09F9	30	<input checked="" type="checkbox"/> Abstract <input type="checkbox"/>
						<input type="checkbox"/> <input type="checkbox"/>

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*Matthew C. J. Lee**6/17/05*

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